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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	09/954,500
Filing Date	17 September 2001
First Named Inventor	Alexander Streltsov
Group Art Unit	1752
Examiner Name	Unknown
Attorney Docket Number	

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	T ²
		RR Krchnavek, GR Lalk, and DH Hartman, "Laser direct writing of channel waveguides using spin-on polymers", J. Appl. Phys. 66 (11), 1 December 1989, pp. 5156-5160.	
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		NF Borelli, CM Smith, and DC Allan, "Excimer-laser-induces densification in binary silica glasses", Optics Letters, Vol. 24, No. 20, pp. 25-27.	
		K. Miura, J. Qiu, H. Inouye, T. Mitsuyu, and K. Hirao, "Photowritten optical waveguides in various glasses with ultrashort pulse laser", Appl. Phys. Letter 71 (23), 8 December 1997, pp. 3329-3331.	
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		K. Hirao and K. Miura, Technical Digest International Workshop on Structure and Functional Optical Properties of Silica and Silica-Related Glasses, "Writing waveguides in silica-related glasses with femtosecond laser", July 10-11, 1997, pp. 103-105.	

Examiner Signature		Date Considered	
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